



ITm

Docket No.: SON-2563  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Koichiro Shoji

Application No.: 10/501,155

Confirmation No.: 5207

Filed: July 13, 2004

Art Unit: 1792

For: SURFACE TREATMENT METHOD,  
SEMICONDUCTOR DEVICE, METHOD OF  
FABRICATION SEMICONDUCTOR DEVICE  
AND TREATMENT APPARATUS

Examiner: N. R. Blan

**STATUS INQUIRY**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Madam:

It is respectfully requested that the representative named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive a response to our Amendment in Response to Non-Final Office Action filed April 17, 2009.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. SON-2563 from which the undersigned is authorized to draw.

Dated: July 14, 2009

Respectfully submitted,

By 

Christopher M. Tobin

Registration No.: 40,290

RADER, FISHMAN & GRAUER PLLC

Correspondence Customer Number: 23353

Attorney for Applicant